



Attorney Docket No.: 0553-0404

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: )  
)  
Osamu NAKAMURA )  
)  
Serial No.: 10/809,118 )  
)  
Filed: March 25, 2004 )  
)  
For: Semiconductor Device And )  
Manufacturing Method Thereof )  
)  
Examiner: )  
)  
Art Unit: )

I hereby certify that this correspondence  
is being deposited with the United States  
Postal Service as first class mail in an  
envelope addressed to:  
Commissioner for Patents, P.O. Box 1450,  
Alexandria, VA 22313-1450, on 9/16/04

Shannon Wallace

Date: September 16 2004

Commissioner for Patents  
P. O. Box 1450  
Alexandria, VA 22313-1450

**PRELIMINARY AMENDMENT A**

Prior to examination and calculation of fees, please amend the above-identified application as follows: